



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG830635477
Report verification at igi.org

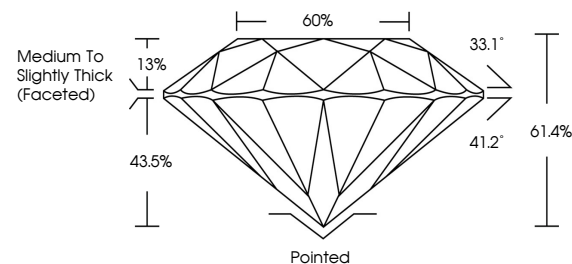
August 21, 2026	
IGI Report Number	LG830635477
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.30 - 7.36 X 4.50 MM
GRADING RESULTS	
Carat Weight	1.50 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG830635477

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

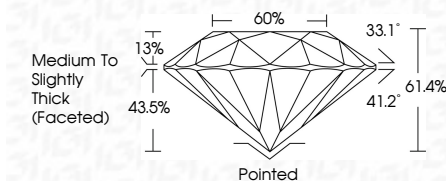
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

August 21, 2026
GI Report No LG830635477
ROUND BRILLIANT

0.90 - 3.30 x 4.50 MM	Carat Weight	1.50 CARAT
	Color Grade	E
	Clarity Grade	VVS 2
	Cut Grade	EXCELLENT
	Depth	61.4%
	Table	60%
	Girdle	Medium To Slightly Thick (Faceted)
	Culet	Poished
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Identification	F18127G-123456789

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.